FIG. 1

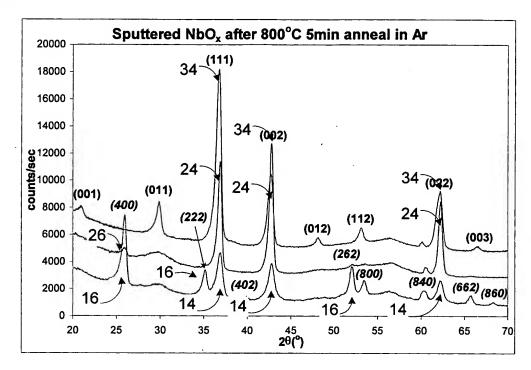


FIG. 2

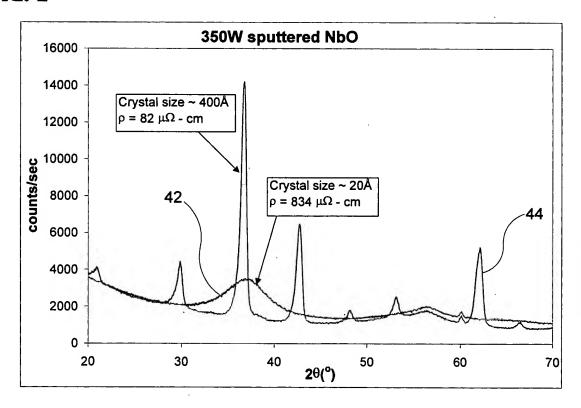


FIG. 3

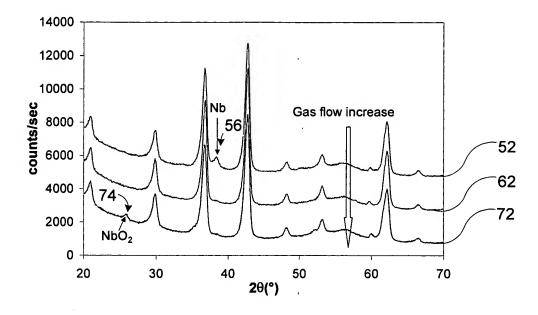
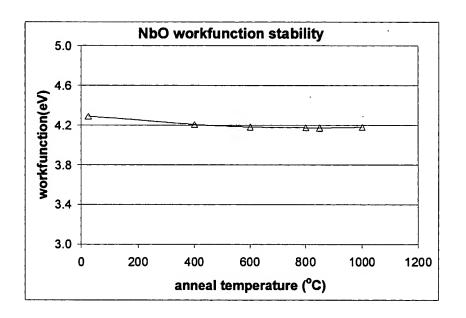
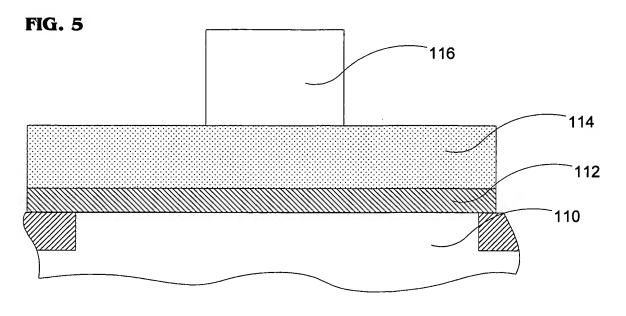
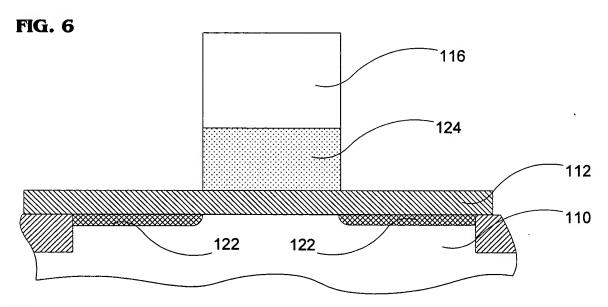


FIG. 4

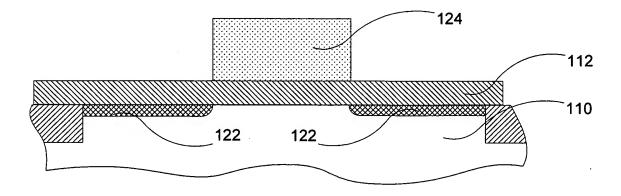


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FIG. 8

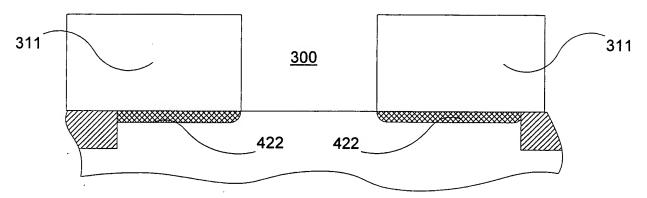


FIG. 9

